

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: **S. SHIRAYONE, et al.**

Application No.: **10/791,856**

Filed: **MARCH 4, 2004**

For: **METHOD FOR PROCESSING PLASMA PROCESSING APPARATUS**

Group AU: **1746**

Examiner: **Zeinab El Arini**

Confirm. No.: **5252**

AMENDMENT

Mail Stop: AMEND – NO FEE

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

September 27, 2007

SIR:

In response to the Office Action dated June 28, 2007, please amend the above-identified application as listed below and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.